

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 09/755,673
Filing Date January 5, 2001
Inventor Forbes et al.
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner K.D. Nguyen
Attorney Docket No. MI22-1531
Title: Methods of Forming Capacitor Structures, and Capacitor Structures

Assistant Commissioner for Patents
Washington, D.C. 20231

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*6/Response
T. Steptoe
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To: Box NON FEE Amendment, VIA FAX: 703-872-9318
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AMENDMENTS**Amendments to Claims**

None.

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